Refine Search

Search Results -

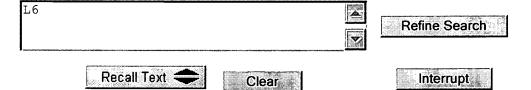
Terms	Documents
L5 and ((retaining or support) near8 (nitride or nitrogen))	82

US Pre-Grant Publication Full-Text Database
US Patents Full-Text Database
US OCR Full-Text Database

Database:

EPO Abstracts Database JPO Abstracts Database Derwent World Patents Index IBM Technical Disclosure Bulletins

Search:



Search History

DATE: Wednesday, May 24, 2006 Printable Copy Create Case

Set Name side by side	Query	<u>Hit</u> Count	Set Name result set
DB=P	GPB, USPT, USOC, EPAB, JPAB, DWPI, TDBD; PLUR=YES; OP=ADJ		
<u>L6</u>	L5 and ((retaining or support) near8 (nitride or nitrogen))	82	<u>L6</u>
<u>L5</u>	L4 and L3	672	<u>L5</u>
<u>L4</u>	(etch\$ or remov\$) near6 oxide	160908	<u>L4</u>
<u>L3</u>	((retaining or support\$) same (etch\$ or remov\$) same (capacitor or storage node))	4883	<u>L3</u>
DB=USPT; PLUR=YES; OP=ADJ			
<u>L2</u>	L1 and ((retaining or support\$) same (etch\$ or remov\$))	77	<u>L2</u>
<u>L1</u>	438/397.ccls.	503	<u>L1</u>

END OF SEARCH HISTORY